

<b>Notice of References Cited</b>	Application/Control No. 09/864,456	Applicant(s)/Patent Under Reexamination KAKU, TOSHIHIKO	
	Examiner Srirama Channavajjala	Art Unit 2164	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,587,596	07-2003	Haeberli, Paul	382/283
	B	US-6,606,411	08-2003	Loui et al.	382/224
	C	US-6,351,556	02-2002	Loui et al.	382/164
	D	US-6,549,913	04-2003	Murakawa, Akira	707/104.1
	E	US-5,740,267	04-1998	Echerer et al.	382/132
	F	US-5,563,722	10-1996	Norris, Christopher	358/453
	G	US-6,804,684	10-2004	Stubler et al.	707/104.1
	H	US-6,609,135	08-2003	Omori et al.	707/104.1
	I	US-2003/0084065	05-2003	Lin et al.	707/104.1
	J	US-2002/0188602	12-2002	Stubler et al.	707/3
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	EP1077414A2	02-2001	European	Land, Stephen et al.	17/30
	O	WO 03/038680 A2	05-2003	PCT	Lin, Qian et al.	17/30
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.